

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

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Katsuhiko MIYA, et al.

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For: SUBSTRATE PROCESSING APPARATUS

VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart Japanese application dated October 16, 2007 and that this communication, to the best of applicant's knowledge, was not received by any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of this Submission.

In the event the any actual fee is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

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